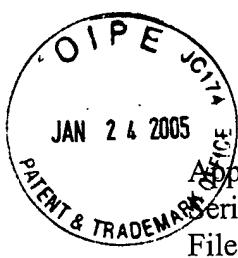


JRW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tatsuya Arao et al. Art Unit : 2815
Serial No. : 10/622,584 Examiner : N. Drew Richards
Filed : July 21, 2003 Confirmation No.: 4703
Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 22, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.

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